



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 7, 2024	
IGI Report Number	LG647409888
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	11.32 X 11.10 X 7.14 MM

GRADING RESULTS

Carat Weight	8.06 CARATS
Color Grade	H
Clarity Grade	VS 1

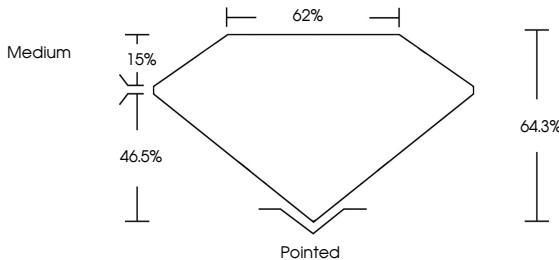
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG647409888

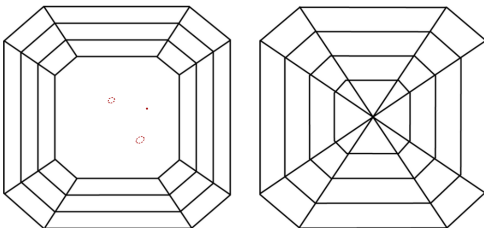
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG647409888
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

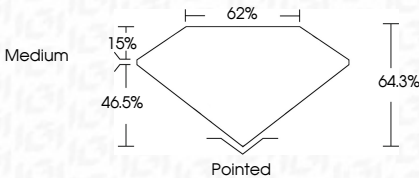
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Fluorescence	NONE
Inscription(s)	LG LG64740988
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IGI



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August 7, 2024
 IGI Report No LG647409888
 SQUARE EMERALD CUT

Carat Weight	VS 1	Polished
Color Grade	64.3%	EXCELLENT
	62%	EXCELLENT
	Medium	NONE
		1691 LG471AD09888

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created by Chemical Vapor Deposition
(CVD) growth process.
Type IIa